

TECHNICAL REPORT

**Dynamic modules –
Part 6-6: Design guide – Failure mode effect analysis for optical units of dynamic
modules**

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Dynamic modules –

Part 6-6: Design guide – Failure mode effect analysis for optical units of dynamic modules

INTERNATIONAL
ELECTROTECHNICAL
COMMISSION

ICS 33.180.20

ISBN 978-2-8322-3719-9

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INTERNATIONAL ELECTROTECHNICAL COMMISSION

DYNAMIC MODULES –

**Part 6-6: Design guide – Failure mode effect analysis
for optical units of dynamic modules**

FOREWORD

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The main task of IEC technical committees is to prepare International Standards. However, a technical committee may propose the publication of a technical report when it has collected data of a different kind from that which is normally published as an International Standard, for example "state of the art".

IEC 62343-6-6, which is a Technical Report, has been prepared by subcommittee 86C: Fibre optic systems and active devices, of IEC technical committee 86: Fibre optics.

This second edition cancels and replaces the first edition published in 2011. It constitutes a technical revision.

This edition includes the following significant technical changes with respect to the previous edition:

- a) addition of the LCOS based and the DLP based wavelength selective switch (WSS);

b) addition of the multicast optical switch module (MCOS).

The text of this technical report is based on the following documents:

DTR	Report on voting
86C/1396/DTR	86C/1421/RVC

Full information on the voting for the approval of this technical report can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

A list of all parts in the IEC 62343 series, published under the general title *Dynamic modules*, can be found on the IEC website.

The committee has decided that the contents of this publication will remain unchanged until the stability date indicated on the IEC web site under "<http://webstore.iec.ch>" in the data related to the specific publication. At this date, the publication will be

- reconfirmed,
- withdrawn,
- replaced by a revised edition, or
- amended.

A bilingual version of this publication may be issued at a later date.

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DYNAMIC MODULES –

Part 6-6: Design guide – Failure mode effect analysis for optical units of dynamic modules

1 Scope

This part of IEC 62343, which is a Technical Report, describes failure mode effect analysis (FMEA) for optical units of dynamic modules. FMEA is one of the effective and useful analysis methods to determine the reliability evaluation test items and conditions that are defined in future reliability qualification documents.

In order to estimate the lifetime for a module, there is a typical procedure. The first step is to identify the dominant failure modes. The second step is to determine the acceleration tests according to these failure modes. The third step is to carry out the test. The fourth step is to estimate the acceleration factors. Finally, the fifth step is to calculate the lifetime of the dynamic module.

IEC 61300-2 (all parts) defines environment and mechanical tests. This Technical Report describes the dominant failure mode for dynamic modules and relevant tests from IEC 61300-2 (all parts).

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

IEC 61300-2-1, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-1: Tests – Vibration (sinusoidal)*

IEC 61300-2-4, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-4: Tests – Fibre/cable retention*

IEC 61300-2-9, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-9: Tests – Shock*

IEC 61300-2-17, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-17: Tests – Cold*

IEC 61300-2-18, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-18: Tests – Dry heat – High temperature endurance*

IEC 61300-2-19, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-19: Tests – Damp heat (steady state)*

IEC 61300-2-22, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-22: Tests – Change of temperature*

IEC 61300-2-44, *Fibre optic interconnecting devices and passive components – Basic test and measurement procedures – Part 2-44: Tests – Flexing of the strain relief of fibre optic devices*

3 Terms and definitions

No terms and definitions are listed in this document.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- IEC Electropedia: available at <http://www.electropedia.org/>
- ISO Online browsing platform: available at <http://www.iso.org/obp>

4 Consideration of types of dynamic modules

There are many types of dynamic modules: dynamic channel equalizer, tuneable optical chromatic dispersion compensator, dynamic gain tilt equalizer, wavelength selective switch, wavelength blocker, optical performance monitor, optical switch, and so on. The main feature of dynamic modules is to control their performances during operation. In order to achieve their features, many kinds of control mechanisms are used for dynamic modules; micro electro mechanical system (MEMS), stepping motor, electromagnet, thermo optics, magnet optics, electro optics, liquid crystal device (LCD), and so on.

Table 1 shows the first guidance of categorization of dynamic modules and their mode of evaluation. Dynamic modules without an electrical circuit board can be considered similar to passive optical components for purposes of evaluation. On the other hand, for dynamic modules with a control circuit board, it is necessary to give special consideration. There are mainly two types of internal design for dynamic modules: those for which it is easy to divide the constituting parts to consider the reliability, and those for which it is not easy to divide. It is necessary to consider how to evaluate according to these structures.

This document describes FMEA only for optical units for dynamic modules. It is necessary to evaluate whole dynamic modules including control circuit boards and firmware if used.

5 Typical failure points

In addition to control circuit boards and control of moving parts, a typical optical unit for a dynamic module consists of the following parts: optical element, outer package, fibre pigtails, optical semiconductor chips, and joint points of these elements. These elements have their own failure mode; for example, break for pigtails and displacement for joint points. Moreover, these elements may have their acceleration factor of degradation; for example, joint points fixed by adhesive are generally weak against high humidity. This failure mode analysis can be referred to FMEA for passive optical components (refer to IEC 62005-3).

There are special considerations for dynamic modules. The following are some examples:

- when using MEMS, operating shock and vibration test are necessary because MEMS are sensitive to mechanical shock and vibration;
- when temperature control is used, the temperature cycling test is recommended because temperature control functions generally produce thermal stress;
- The temperature cycling test can accelerate thermal stress.

6 Failure modes and known failure mechanisms

For some dynamic modules, FMEA is carried out. Table 2 shows known failure mechanisms, failure effects, failure modes, relevant tests, and IEC test document numbers for dynamic modules. If new technology and new dynamic modules become commercially available, they will be added to Table 2 in later revisions of this document. Relevant tests are listed with the failure effect and the dominant failure mechanism. As other relevant tests or methods of failure mode excitation become known, these will also be added.

Table 1 – Categorization based on the structure and mode of evaluation

Electrical circuits		How to evaluate	Examples
Without electrical circuits	N.A.	As optical component	VOA, 1x2/2x2 optical switch, DGTE
With electrical circuit	Easy to divide optical and electrical unit	As optical and electrical units individually, and as integrated dynamic module	VOA, VOA-MUX, TDC (DCDC), DCE, matrix switch, channel monitor, performance monitor
	Difficult to divide optical and electrical unit	To evaluate as integrated dynamic module	Wavelength blocker (WB), Wavelength selective switch (WSS)
<p>Optical active and passive components should comply with the reliability qualification requirement defined in IEC 62572 (all parts) for active components and IEC 62005-9 (all parts) for passive optical components, respectively. In cases in which it is difficult to divide optical and electrical units, integrated modules should be tested.</p> <p>Electrical circuit boards should be qualified individually. The following standards series are useful references for the quality of electrical circuit boards: IEC 61188 (all parts), IEC 61189 (all parts), IEC 61190 (all parts), and IEC 61191 (all parts).</p> <p>Three pieces should be tested.</p>			

Table 2 – Failure mode and known failure mechanisms for the optical units of dynamic devices

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
Variable optical attenuators	MEMS	Stacking the moving part	Uncontrollable	Mechanical stress Excess driving power	Shock (storage) Vibration (storage) Maximum absolute rating test (electrical) On/off driving test	IEC 61300-2-9 IEC 61300-2-1 Under study Under study
		Distortion of hinge/mirror	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Mechanical stress Thermal stress Excess driving power	Shock (storage) Vibration (storage) Shock and vibration (operating) Change of temperature Maximum absolute rating test On/off driving test	IEC 61300-2-9 IEC 61300-2-1 Under study IEC 61300-2-22 Under study Under study
	Collimator	Reflectance of mirror changing	Insertion loss increase Attenuation change Return loss decrease PDL increase WDL increase	High humidity (non-hermetic sealed)	Damp heat	IEC 61300-2-19
		Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Dynamic range of attenuation decrease PDL increase WDL increase	Thermal stress High humidity (non-hermetic sealed and using adhesive) Mechanical stress	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1
	Pigtail	Fibre broken, micro-bending	Insertion loss increase No operation	Mechanical stress for pigtail	Fibre cable retention Optical fibre cable flexing	IEC 61300-2-4 IEC 61300-2-44

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
Liquid crystal type	LCD	Degradation of LCD	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Thermal stress High humidity (non-hermetic sealed) Mechanical stress	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1
		Electrical polarization of LCD	Uncontrollable	Excess driving power	Maximum absolute rating test On/off driving test	Under study Under study
Magnet optic type	Collimator Pigtail	Freezing of LCD	Uncontrollable	Low temperature	Cold	IEC 61300-2-17
		Same as MEMS type				
Magnet optic type	Magnet optic part	Dislocation of magnet, Faraday rotator and birefringent crystal	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Thermal stress High humidity (non-hermetic sealed and using adhesive) Mechanical stress	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1
		Same as MEMS type				
Mechanical type	Collimator Pigtail	Same as MEMS type				
		Same as MEMS type				
Mechanical type	Moving part	Stacking the moving part	Uncontrollable	Mechanical stress High humidity (non-hermetic) Excess driving power	Shock (storage) Vibration (storage) Damp heat Maximum absolute rating test (electrical) On/off driving test	IEC 61300-2-9 IEC 61300-2-1 IEC 61300-2-19 Under study Under study

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
		Degradation of moving part	Driving power increase	Mechanical stress Thermal stress Excess driving power High humidity (non-hermetic sealed)	Shock (storage) Vibration (storage) Shock and vibration (operating) Change of temperature Maximum absolute rating test On/off driving test Damp heat	IEC 61300-2-9 IEC 61300-2-1 Under study IEC 61300-2-22 Under study Under study IEC 61300-2-19
		Distortion of mirror	Insertion loss increase Return loss decrease Crosstalk increase PDL increase	Mechanical stress Thermal stress Excess driving power	Shock (storage) Vibration (storage) Change of temperature Maximum absolute rating test On/off driving test	IEC 61300-2-9 IEC 61300-2-1 IEC 61300-2-22 Under study Under study
		Reflectance of mirror changing	Insertion loss increase Attenuation change Return loss decrease PDL increase WDL increase	High humidity (non-hermetic sealed)	Damp heat	IEC 61300-2-19
	Collimator	Same as MEMS type				
	Pigtail	Same as MEMS type				
Planar waveguide type (thermal optic effect)	Waveguide	Refractive index changing	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase	Thermal stress High humidity (non-hermetic sealed and using adhesive) Mechanical stress	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references	
Optical switches		Electrode degradation	Dynamic range of attenuation decrease	High humidity (non-hermetic sealed and using adhesive) Excess driving power	Damp heat Maximum absolute rating test Diving test	IEC 61300-2-19 Under study Under study	
		Fixing point between waveguide and fibres	Insertion loss increase	Thermal stress High humidity (non-hermetic sealed and using adhesive)	Change of temperature Damp heat	IEC 61300-2-22 IEC 61300-2-19	
		Pigtail	Same as MEMS type				
	Mechanical type	Moving part	Stacking the moving part	Uncontrollable	Same as VOA mechanical type		
			Degradation of moving part	Driving power increase Switching time increase	Same as VOA mechanical type		
			Distortion of mirror	Insertion loss increase Return loss decrease Crosstalk increase PDL increase	Same as VOA mechanical type		
			Reflectance of mirror changing	Insertion loss increase Return loss decrease PDL increase WDL increase	Same as VOA mechanical type		
			Same as VOA MEMS type	Insertion loss increase Crosstalk increase PDL increase WDL increase	Same as VOA mechanical type		
			Collimator	Same as VOA MEMS type			
			Pigtail	Same as VOA MEMS type			
		Waveguide	Refractive index changing	Insertion loss increase Crosstalk increase Return loss decrease PDL increase	Same as VOA PLC TO type		
Planar waveguide type (thermal optic effect)							

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
	Fixing point between waveguide and fibres	Electrode degradation Dislocation by the degradation of adhesive	Crosstalk increase Insertion loss increase	Same as VOA PLC TO type Same as VOA PLC TO type		
	Pigtail	Same as VOA MEMS type				
MEMS type	MEMS	Stacking the moving part Distortion of hinge/mirror	Uncontrollable Insertion loss increase Crosstalk increase Return loss decrease PDL increase WDL increase	Same as VOA MEMS type Same as VOA MEMS type		
		Reflectance of mirror changing	Insertion loss increase Crosstalk increase Return loss decrease PDL increase WDL increase	Same as VOA MEMS type		
	Collimator	Same as VOA MEMS type	Same as VOA MEMS type except: Crosstalk increase instead of attenuation change	Same as VOA MEMS type		
	Pigtail	Same as VOA MEMS type				

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
Electrical optics type (LN)	Waveguide	Refractive index changing	Insertion loss increase Crosstalk increase Driving voltage changing	Thermal stress Mechanical stress Excess driving power	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage) Maximum absolute rating test Diving test	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1 Under study Under study
	Fixing point between waveguide and fibres	Electrode degradation Dislocation by the degradation of adhesive	Crosstalk increase Insertion loss increase	Same as switch PLC TO (VOA PLC TO) type Same as switch PLC TO (VOA PLC TO) type		
Tunable filters (electrical control)	Pigtail	Same as VOA MEMS type				
	MEMS	Stacking the moving part Distortion of hinge/mirror	Uncontrollable Insertion loss increase Centre-wavelength change Return loss decrease PDL increase FWHM increase Tunable wavelength range decrease	Same as VOA MEMS type Same as VOA MEMS type		
MEMS etalon type	Reflectance of etalon mirror changing	Insertion loss increase Centre-wavelength change Return loss decrease PDL increase FWHM increase	Same as VOA MEMS type			

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
PZT etalon type	Collimator	Same as VOA MEMS type	Insertion loss increase Centre-wavelength change Return loss decrease PDL increase FWHM increase Tunable wavelength range decrease	Same as VOA MEMS type		
	Pigtail	Same as VOA MEMS type				
	PZT	PZT degradation	Driving voltage increase	High humidity Thermal stress Excess driving	Damp heat Change of temperature Maximum absolute rating test On/off driving test	IEC 61300-2-19 IEC 61300-2-22 Under study Under study
	Etalon mirror	Reflectance of etalon mirror changing	Insertion loss increase Centre-wavelength change Return loss decrease PDL increase FWHM increase	Same as VOA MEMS type		
	Optical part and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Centre-wavelength change FWHM increase Tunable wavelength range decrease	Thermal stress High humidity (non-hermetic sealed and using adhesive) Mechanical stress	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1
	Pigtail	Same as VOA MEMS type				
	Thin film filter mechanical	Moving part	Stacking the moving part	Uncontrollable	Same as VOA mechanical type	
			Degradation of moving part	Driving power increase	Same as VOA mechanical type	

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
control type		Thin film filter degradation	Insertion loss increase Centre-wavelength change FWHM increase	High humidity (non-hermetic sealed)	Damp heat	IEC 61300-2-19
	Collimator	Same as VOA MEMS type	Insertion loss increase Centre-wavelength change Return loss decrease PDL increase FWHM increase Tuneable wavelength range decrease	Same as VOA MEMS type		
Dynamic chromatic dispersion compensators	Pigtail	Same as VOA MEMS type				
	Moving part	Degradation of stepping motor	Uncontrollable Dynamic range of CD decrease	Thermal stress Mechanical stress Excess driving High humidity (non-hermetic)	Shock (storage) Vibration (storage) Shock and vibration (operating) Change of temperature Maximum absolute rating test On/off driving test Damp heat	IEC 61300-2-9 IEC 61300-2-1 Under study IEC 61300-2-22 Under study Under study IEC 61300-2-19
	VIPA mirror	Distortion of VIPA mirror	Centre-wavelength change Insertion loss increase GDR increase	Thermal stress High humidity (non-hermetic) Mechanical stress	Change of temperature Damp heat High temperature Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-19 IEC 61300-2-18 IEC 61300-2-9 IEC 61300-2-1

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
		Temperature uncontrollable	Centre-wavelength change Insertion loss increase	Thermal stress High humidity (non-hermetic) Mechanical stress	Change of temperature Damp heat High temperature Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-19 IEC 61300-2-18 IEC 61300-2-9 IEC 61300-2-1
	Optical parts and collimator	Dislocation of fixing points of optical parts (3D mirror distortion)	Insertion loss increase Centre-wavelength change Dynamic range of DC decrease GDR increase	Thermal stress High humidity (non-hermetic sealed and using adhesive) Mechanical stress	Change of temperature Damp heat High temperature Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-19 IEC 61300-2-18 IEC 61300-2-9 IEC 61300-2-1
FBG thermal control type	Pigtail	Same as VOA MEMS type				
	Thermal control part	TEC/heater degradation	Insertion loss increase Wavelength range change Dynamic range of CD decrease	Thermal stress High humidity (non-hermetic) Mechanical stress Excess driving	Change of temperature Damp heat High temperature Shock (storage) Vibration (storage) Maximum absolute rating test On/off driving test	IEC 61300-2-22 IEC 61300-2-19 IEC 61300-2-18 IEC 61300-2-9 IEC 61300-2-1 Under study Under study
	Fixing point between FBG and temperature control	Fibre bending	Insertion loss increase Wavelength range change CD changing GDR increase	Thermal stress High humidity (non-hermetic) Mechanical stress	Change of temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1
	FBG	Refractive index changing	CD changing	High temperature	High temperature	IEC 61300-2-18
	Pigtail	Same as VOA MEMS type				

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
Dynamic gain tilt equalizers	Magnet optic part	Dislocation of magnet, Faraday rotator and birefringent crystal	Insertion loss increase Tilt change Return loss decrease PDL increase WDL increase	Same as VOA MO type		
	Collimator	Same as VOA MEMS type	Insertion loss increase Tilt change Return loss decrease PDL increase WDL increase	Same as VOA MEMS type		
Planar waveguide type	Pigtail	Same as VOA MEMS type				
	Waveguide	Refractive index changing	Insertion loss increase Tilt change Return loss decrease PDL increase WDL increase	Same as VOA PLC TO type		
	Fixing point between waveguide and fibres	Dislocation by the degradation of adhesive	Insertion loss increase	Same as VOA PLC TO type		
Dynamic channel equalizers	Pigtail	Same as VOA MEMS type				
	MEMS	Stacking the moving part Distortion of hinge/mirror	Uncontrollable Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as VOA MEMS type Same as VOA MEMS type		

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
		Reflectance of mirror changing	Insertion loss increase Attenuation change Return loss decrease PDL increase WDL increase	Same as VOA MEMS type		
		Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Thermal stress High humidity (non-hermetic sealed and using adhesive) Mechanical stress	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1
	Pigtail	Same as VOA MEMS type				
Liquid crystal and diffractive grating type	LCD	Degradation of LCD	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as VOA LCD type		
		Electrical polarization of LCD	Uncontrollable	Same as VOA LCD type		
		Freezing of LCD	Uncontrollable	Same as VOA LCD type		

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
	Diffraction grating, lens, prism and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as DCE MEMS type		
	Pigtails	Same as VOA MEMS type				
Wavelength blockers	MEMS	Stacking the moving part Distortion of hinge/mirror	Uncontrollable Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as VOA MEMS type Same as VOA MEMS type		
		Reflectance of mirror changing	Insertion loss increase Attenuation change Return loss decrease PDL increase WDL increase	Same as VOA MEMS type		

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
	Diffractive grating, lens, prism and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as DCE MEMS type		
	Pigtail	Same as VOA MEMS type				
Liquid crystal and diffractive grating type	LCD	Degradation of LCD	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as VOA LCD type		
		Electrical polarization of LCD	Uncontrollable	Same as VOA LCD type		
		Freezing of LCD	Uncontrollable	Same as VOA LCD type		
	Diffractive grating, lens, prism and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as DCE MEMS type		
	Pigtail	Same as VOA MEMS type				

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
Wavelength selectable switches	MEMS and diffractive grating type	Stacking the moving part Distortion of hinge/mirror	Uncontrollable Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as VOA MEMS type Same as VOA MEMS type		
	MEMS	Reflectance of mirror changing	Insertion loss increase Attenuation change Return loss decrease PDL increase WDL increase	Same as VOA MEMS type		
	Diffractive grating, lens, prism and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as DCE MEMS type		
	Pigtails	Same as VOA MEMS type				
	DLP	Stacking the moving parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease	Same as WSS MEMS type		
DLP and diffractive grating type						

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
		Reflectance of mirror changing	Insertion loss increase Attenuation change Return loss decrease PDL increase WDL increase	Same as WSS MEMS type		
	Diffractive grating, lens, prism and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as WSS MEMS type		
	Pigtails	Same as VOA MEMS type				
Liquid crystal and diffractive grating type	LCD	Degradation of LCD	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as VOA LCD type		
		Electrical polarization of LCD	Uncontrollable	Same as VOA LCD type		
		Freezing of LCD	Uncontrollable	Uncontrollable	Same as VOA LCD type	

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
	Diffractive grating, lens, prism and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as DCE MEMS type		
	Pigtail	Same as VOA MEMS type				
LCOS and diffractive grating type	LCOS	Degradation of LCD	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as WSS LCD type		
		Electrical polarization of LCD	Uncontrollable	Same as WSS LCD type		
		Freezing of LCD	Uncontrollable		Same as WSS LCD type	
		Diffractive grating, lens, prism and collimator	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Same as DCE MEMS type	
	Pigtail	Same as VOA MEMS type				

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
Planar waveguide type (thermal optic effect)	Waveguide	Refractive index changing	Insertion loss increase Crosstalk increase Return loss decrease PDL increase	Same as VOA PLC TO type		
		Electrode degradation	Crosstalk increase	Same as VOA PLC TO type		
	Fixing point between waveguide and fibres	Dislocation by the degradation of adhesive	Insertion loss increase	Same as VOA PLC TO type		
	Pigtail	Same as VOA MEMS type				
Planar waveguide and MEMS type	MEMS	Stacking the moving part	Uncontrollable	Same as VOA MEMS type		
		Distortion of hinge/mirror	Insertion loss increase Isolation decrease Return loss decrease PDL increase WDL increase	Same as VOA MEMS type		
		Reflectance of mirror changing	Insertion loss increase Isolation decrease Return loss decrease PDL increase WDL increase	Same as VOA MEMS type		
	Waveguide	Refractive index changing	Insertion loss increase Attenuation change Isolation decrease Return loss decrease PDL increase WDL increase	Same as VOA PLC TO type		

Dynamic devices	Constitution parts	Known failure mechanisms	Failure modes	Degradation acceleration factors	Relevant tests	IEC references
	Fixing point between waveguide and fibres	Dislocation by the degradation of adhesive	Insertion loss increase	Same as VOA PLC TO type		
	Fixing point of MEMS, lens and mirror	Dislocation of fixing points of optical parts	Insertion loss increase Attenuation change Isolation decrease Return loss decrease Dynamic range of attenuation decrease PDL increase WDL increase	Thermal stress High humidity (non-hermetic sealed and using adhesive) Mechanical stress	Change of temperature High temperature Damp heat Shock (storage) Vibration (storage)	IEC 61300-2-22 IEC 61300-2-18 IEC 61300-2-19 IEC 61300-2-9 IEC 61300-2-1
	Pigtail	Same as VOA MEMS type				
Channel monitors (Performance monitors)	MEMS	Stacking the moving part	Uncontrollable	Same as VOA MEMS type		
		Distortion of hinge/mirror	Wavelength deviation Wavelength dynamic range change	Same as VOA MEMS type		
		Reflectance of mirror changing	PD current decrease (Error-increase)	Same as VOA MEMS type		
	PD	PD degradation	PD dark current increase	Electrical surge High temperature Excess driving	ESD High temperature Maximum absolute rating test	Under study IEC 61300-2-28 Under study
	Collimator	Dislocation of fixing points of optical parts	PD current decrease (Error-increase) Return loss decrease	Same as VOA MEMS type		
	Pigtail	Same as VOA MEMS type				